Low Distortion Embedding from Edit to Hamming Distance using Coupling

Abstract:

The Hamming and the edit metrics are two common notions of measuring distances between pairs of strings x, y lying in the Boolean hypercube. The edit distance between x and y is defined as the minimum number of character insertion, deletion, and bit flips needed for converting x into y. Whereas, the Hamming distance between x and y is the number of bit flips needed for converting x to y.

In this paper we study a randomized injective embedding of the edit distance into the Hamming distance with a small distortion. This question was studied by Jowhari (ESA 2012) and is mainly motivated by two questions in communication complexity: the document exchange problem and deciding edit distance using a sketching protocol.

We show a randomized embedding with quadratic distortion. Namely, for any x, y satisfying that their edit distance equals k, the Hamming distance between the embedding of x and y is O(k^2) with high probability. This improves over the distortion ratio of O(log n log^* n) obtained by Jowhari for small values of k. Moreover, the embedding output size is linear in the input size and the embedding can be computed using a single pass over the input.